

DOCKET NO: 296428US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
TSUYOSHI TAKAHASHI, ET AL. : EXAMINER: MILLER, JR, J.A.  
SERIAL NO: 10/593,254 :  
FILED: SEPTEMBER 18, 2006 : GROUP ART UNIT: 1792  
FOR: METHOD AND APPARATUS FOR :  
FORMING METAL SILICATE FILM, AND  
METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE

RESPONSE TO RESTRICTION REQUIREMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated December 2, 2008, please amend the above-identified application as follows:

**Remarks/Arguments** begin on page 2 of this paper.